Joint Research Activities on Charge production with Photo-injectors (PHIN)



Andrea Ghigo on behalf of PHIN collaboration

CARE collaboration meeting



CERN 2-4 December 2008









Coordinator: A. Ghigo

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LRC

PHIN JRA addressed to

- Development of the high charge e⁻ beam (drive beam) for the RF power source of the two-beam linear collider CLIC-CTF3 (CERN).
- Realisation of the first high power photoinjector that uses a photocathode, laser driven, in a superconducting RF gun for application in ELBE (Rossendorf).
- Realisation of high brightness high energy laser driven plasma photoinjector (LOA-Palaiseau)
- Realisation of new electron source for NEPAL (PHIL) (LAL-Orsay) test stand.
- Improve the brightness of SPARC (INFN-Frascati / Milano) photoinjector by longitudinal laser pulse shaping.
- Improve the performance of TEU-FEL (Twente) photoinjector by studying cathodes composition and adding cathode diagnostics

Status of the CTF3 photoinjector



16 September 2008

Status of the CTF3 photoinjector



17 November 2008

Construction of 2 photo-injectors: one for CTF3 and one for LAL



CTF3 - LASER

1.5 GHzOscillator & preamplifier



CTF3 High Power LASER CCLRC-RAL design and realization. CERN-INFN commissioning •1st Amplifier reach nominal power and gain [3.5kW] •Pulse duration < 10ps •Jitter< 1 ps •2nd Amplifier reaches half nominal power.



Amplifiers @ 90A:

power [kW]



On site synchronization measurements

After on site investigation, oscillator cavity perturbations due to thermal effects were suspected

HighQ expert came and fixed the settings of the oscillator end-cavity mirror (semiconductor saturable absorber mirror "SESAM"): **50C** Degree

Problem has been fixed

$$J_{real} = \sqrt{(J_{meas})^2 - (JNF)^2}$$

JNF: jitter noise floor ~ 350 fs Jmeas: 724fs

(rms jitter required <1ps)

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Lecroy SDA (16GHz, 60GS/s+ NewFocus Photodetector25GHz)





CTF3 Photoinjector commissioning

first MTV screen beam spot 1.55 m downstream of RF gun: FWHM ~ 5 mm



Beam Position Monitor Sum Signal

Faraday Cup



electron beam train-to-train intensity fluctuations (BPM): r.m.s < 6% (5 minutes) laser beam train-to-train UV energy fluctuations in laser room: r.m.s < 3% (500 trains)

Energy measurement, 90 deg. Spectrometer



Measured nominal energy with small energy spread (calibration to be checked)

5.3 MeV with 27 keV (0.5 %) r.m.s. energy spread

Construction of a test beamline at LAL

Layout of the accelerator area





Construction of a test beamline at LAL

The civil engineering begun in October 2006





Holes are drilled in the floor, pillars are set-up, then a concrete floor is built

End of civil engineering in March 2007



Construction of a test beamline at LAL



Most of the beamline was installed in July 2008



- 3 GHz
- 2,6 cells
- waveguide
- coupling
- compatible with NEPAL beamline





The Superconducting RF Photoinjector at ELBE



COMMISSIONING – FIRST COOL-DOWN







first cool-down 1 – 2 August 2007



COMMISSIONING – UV LASER INSTALLATION

500 kHz Laser system developed by MBI



262 nm CW laser mit 0.5 W /UV) Nd:YLF oscillator + Nd:YLF regenerative amplifier two-stage frequ. conv. (LBO, BBO) 15 ps FWHM Gaussian

Laser pulse lateral: shaped with aperture to Ø 2.7 mm circular flat top







COMMISSIONING - DIAGNOSTICS BEAMLINE

Beam spot on the first YAG screen in the BESSY diagnostics beamline



ELBE shut-down, Oct. 15 – 26, 2007 Installation of BESSY diagnostics beamline

- Emittance measurement (slit mask)
- C bend (E, ∆E)
- Cherenkov radiatior with optical beamline and streak camera



COMMISSIONING - CATHODE TRANFER SYSTEM INSTALLATION

installation in the shut-downs of ELBE in Jan. + March 08 at the SRF gun





Cs₂Te PHOTO CATHODES

Photo cathode preparation lab at FZD



May 08: First set of Cs₂Te cathodes in the SRF gun



preparation process





BEAM PARAMETER MEASUREMENTS

Transverse Emittance – Solenoid scan

not suitable for space-charge dominated beams,
preliminary method as long as the analysis tools for the installed slit mask method are under development



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Measurement: 5 MV/m gradient, 2 MeV energy laser: 15 ps FWHM Gaussian, 2.7 mm diam. sharp edges launch phase & pulse energy variation



LOA

LOA has completed all their deliverables

Laser plasma acceleration has demonstrated

Energy gains of 1 MeV to 200 MeV
E-fields of 1 GV/m to 1000 GV/m
Good e-beam quality : Emittance < 3πmm.mrad
Charge at high energy
Quasi monoenergetic

Experimental set up



LOA Energy spectrometer permanent magnets





10 cm magnet

40 cm new magnet for GeV e beam

Controlling the injection



A second laser beam is used to heat electrons



Ponderomotive force of beatwave: $F_p \sim 2a_0a_1/\lambda_0$ (a_0 et a_1 can be "weak") Boost electrons locally and injects them INJECTION IS LOCAL and IN FIRST BUCKET

Tunable monoenergetic bunches



Stable monoenergetic beams at 200 MeV



Collaboration with LLR* for resolving small energy spread beams



1% energy spread beams



Conclusion

Two laser beams allows control of many e-beam parameters

- Good beam quality
 - Monoenergetic, collimated beam
 - $\delta E/E$ down to 5 % , dE ~ 5-20 MeV, charge 10's pC
- Beam is stable
- Energy is tunable: 20-300 MeV
- Charge is tunable: 1 to 100 pC
- Energy spread is tunable: 5 to 20 %
- Low energy spread beams at ∆E/E=1%

WHAT'S NEXT ?

- Push energy limit (>1 GeV)
- Measure the bunch duration

(simulation and exp data indicates τ_{bunch} < 10fs)

- Measure the emittance => EUCARD
- Increase injected charge: larger a₁ ?

LOA/CARE_PHIN : contribution 04-08

21 in refereed journals : 2 nature, 1 PRSTAB, 1 EuroPhys Lett, 1 PRL, etc..

50 Invited talks in International Conference

7 proceedings

Thanks to CARE the LOA group got several prizes : Fresnel Prize to Jerome Faure EPS PhD prize to Yannick Glinec IEEE Prize to Victor Malka La Recherche Magazine prize to V. Malka, J. Faure and E. Lefebvre

And ERC senior grant to V. Malka

Many thanks to the "accelerators" community for their supports and for hosting our approach in their program at a early, at a time where nothing (or quite) Was yet achieved.

Victor Malka

Cesium-telluride PVD diagnostics @University of Twente



Ellipsometer mounted above photocathode preparation chamber

- Diagnostics for cesium-telluride Physical Vapour Deposition (PVD) based on ellipsometry
- Interferometric ellipsometry attempted => failed due to vibration of deposition surface
- Alternative method Rotating Compensator Ellipsometry attempted => successful, interpretation of results remains a challenge

Interferometric Ellipsometry



D1 & D3 measuring <u>amplitude</u> of reflected beam

• D2 & D4 measuring interference between reflected beam and reference beam, giving information about the <u>phase</u> of the reflected beam.

•Vibrations make interference signal unstable.



<u>Conclusion</u>: interferometric ellipsometry in this case seems impractical, requires major changes to the deposition system to work.

Rotating Compensator Ellipsometry



- Incident beam polarization is manipulated by rotating a quarter wave plate (QWP)
- Reflected beam is measured after a polarizer
- Intensity after the polarizer is measured as a function of QWP angle
- Fourier and Mueller matrix analysis give sample properties psi and delta
- => method successful



IR programmable pulse shapers

DAZZLER LC-SLM liquid ITO gap crystal electrodes glass plates ITO ground plane **Acoustic grating** Fast mode 🛏 100 µm m3 200 mm pm $\theta_{in} = 40^{\circ}$ m2 **Slow mode** $\theta_{d} = 69.6^{\circ}$ f = 250 mmm4 g = 2000 l / mmg2 $1nm \rightarrow 1.4mm(14 \, pixels)$ $w_0 = 2mm \rightarrow w = 70 \,\mu m$ f = 250 mm 150 mm $\Delta \tau_{\rm max} = 10 \, ps$

Acousto-optic interaction in a TeO₂ crystal

IR shapers Features:

DAZZLER

- Compact
- Easy alignment
- Simultaneously phase
 +amplitude modulation
- Losses within 50%
- Resolution = 0.3 nm
- Slow optimization



Rise and fall time ~ 2.6 ps

LC-SLM

- Not-compact
- Not easy alignment
- Phase only modulation
- Losses within 50%
- Resolution<0.1 nm
- Fast optimization



Rise and fall time ~ 2.1 ps

UV pulse shaper

In the Fourier plane an amplitude filter, such as an iris, can be applied to cut the tails of an almost square spectrum produced by the DAZZLER or LC-SLM, the obtained spectrum profile is transferred into the time profile by the stretcher





UV time jitter: measure at 10 Hz



•To reduce the time jitter we can synthesize the RF frequency from a photodiode excited by the oscillator pulses.





Time of arrival jitter estimated with the RF deflector is 390 fs



SPARC emittance measurements



Gaussian vs flat beam:comparison



PHIN collaboration produced 115 papers

	PUBL	CONF	NOTES	REPORT	THESIS
2004	2	6	2	1	
2005	5	2	1	6	1
2006	13	11	1	5	1
2007	3	11		8	
2008	6	13	9	8	
тот	29	43	13	28	2

Conclusions

- We achieved the results foreseen in the PHIN project
- We accumulated delay in the construction of components but all deliverables will be completed before the end of the year
- The experience in PHIN Joint Research Activities is a great success in terms of new photoinjectors realization and in scientific and technological achievements.
- All the work has been realized in collaborative and friendly atmosphere with real international scientific exchange
- Thanks to CARE ESGARD and welcome EuCARD